

<b>Notice of References Cited</b>	Application/Control No. 10/639,144	Applicant(s)/Patent Under Reexamination LU, CHUN CHIAN	
	Examiner Eva Yi Zheng	Art Unit 2611	Page 1 of 1

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*	C	US-2004/0136444	07-2004	Massicotte et al.	375/147
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**NON-PATENT DOCUMENTS**

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